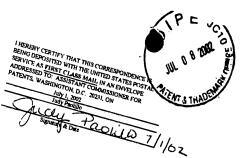
AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Basanth Jagannathan, et al.						Docket No. FIS920010024US1	
1		ng Date I 30, 2001			ian	Group Art Unit 2823	
Invention: Method to Increase Carbon and Boron Doping Concentrations in Si and SiGe Films COPY OF PAPERS ORIGINALLY FILED							
To THE ASSISTANT COMMISSIONER FOR PATENTS: Transmitted here the same amendment in the above-identified application. The fee has been calculated and is transmitted as shown below. CLAIMS AS AMENDED							
		T	- - - - - - - - - -		r	——————————————————————————————————————	
	CLAIMS-REMAINING	HIGHEST#	1	R-EXTRA	RATE	ADDITIONAL	
TOTAL CLAIMS	AFTER AMENDMENT 10 -	PREV. PAID FOR		PRESENT 0	x \$18.	FEE \$0.00	
·	2 -	3 =				·-···	
INDEP. CLAIMS	L	<u> </u>			x \$84.	\$0.00	
		TOTAL ADDITION	NAL FEE FOI	R THIS AMI	ENDMENT	\$0.00	
 No additional fee is required for amendment. □ Please charge Deposit Account No. in the amount of A duplicate copy of this sheet is enclosed. □ A check in the amount of to cover the filing fee is enclosed. ☑ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 09-0458 A duplicate copy of this sheet is enclosed. ☑ Any additional filing fees required under 37 C.F.R. 1.16. ☑ Any patent application processing fees under 37 CFR 1.17. □ Dated: July 1, 2002 							
Joseph P. Abate, Attorney Registration No. 30,238 International Business Machines Corporation Dept. 18G / Bldg. 300-482 2070 Route 52 Hopewell Junction, New York 12533 Phone: 845-894-4633 I certify that this document and fee is being deposited July 1, 2002 with the U.S. Postal Service as class mail under 37 C.F.R. 1.8 and is addressed to Assistant Commissioner for Patents, Washington, 20231.							
Fax: 845-892-6				Gigni	ature of Person	an WW 7/1/02. on Mailing Correspondence	

CC:

Judy Paolillo

Typed or Printed Name of Person Mailing Correspondence





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE In Re Application of BASANTH JAGANNATHAN, ET AL

<u>Serial No.</u> 09/843,783

Filed: April 30, 2001

Title: METHOD TO INCREASE CARBON AND BORON DOPING CONCENTRATIONS IN SI AND SIGE FILMS

July 1, 2002

Group Art No.: 2823

Examiner: William D. Coleman

IBM Corporation Bldg. 300, Zip 482 2070 Route 52 Hopewell Junction, New York 12533

<u>AMENDMENT</u>

Assistant Commissioner for Patents Washington, D.C. 20231

Sir

TECHNOLOGY CENTER 2800 In response to the Office Action dated May 6, 2002, please amend the Application as follows: IN THE CLAIMS:

Kindly amend independent claims 1 and 15 to appear as follows, without prejudice:

FIS920010024US1